



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Farnworth et al.

**Serial No.:** 10/666,930

**Filed:** September 19, 2003

**For:** METHOD FOR SUPPORTING  
WAFERS FOR DIE SINGULATION AND  
SUBSEQUENT HANDLING (as amended)

**Confirmation No.:** 6453

**Examiner:** S. Isaac

**Group Art Unit:** 2812

**Attorney Docket No.:** 2269-5529US  
(02-0766.00/US)

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

1/24/2006

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Erika Gandre

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**RESPONSE TO FINAL OFFICE ACTION**

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Sir:

The following remarks are filed in response to the Examiner's remarks in the Final Office Action mailed November 30, 2005, the three-month shortened statutory period for response to which expires on February 28, 2006. This response is submitted on or before two months from the mailing date of the Final Office Action.

**Remarks** begin on page 2 of this paper.